AMENDMENT TO THE SPECIFICATION:

Please cancel paragraphs 0061 and 0062 from the specification as follows:

[0061] FIG. 1 is a longitudinal cross sectional view
illustrating the structure of a sensor according to a
first-embodiment of the invention;
FIG. 2 is a longitudinal cross sectional view
illustrating the structure of a sensor according to a
second embodiment of the invention;
FIG. 3 is a longitudinal cross sectional view
illustrating the structure of a sensor according to a
third embodiment of the invention; and
FIG. 4 is a perspective view illustrating the
structure of a sensor according to a fourth embodiment of
the invention.
[0062] 1 Greatel (an emtire) consequide soth)
[0062] 1. Crystal (an optical waveguide path)
2. Crystal oscillation electrode
3. Crystal oscillation electrode (optical
waveguide electrode, optical waveguide path)
4. Clad
5. Core
6. Metallic thin film
7. Adsorbed substance detecting thin film
8. Incoming light prism
9. Outgoing light-prism
11. Adsorption member
12. Optical waveguide layer (optical waveguide
path)
15,16-Electrodes

